


<b>Search Notes</b>  	<b>Application/Control No.</b>  10550238	<b>Applicant(s)/Patent Under Reexamination</b>  KIM ET AL.
	<b>Examiner</b>  Heyman, John	<b>Art Unit</b>  2871

<b>SEARCHED</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
349	106, 108, 109	06/26/2007	JSH

<b>SEARCH NOTES</b>		
<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>
Consult Primary Ex'r Andrew Scechter	06/26/2007	JSH

<b>INTERFERENCE SEARCH</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>